



**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT PTO-1449**

Docket No. <b>52433/820</b>	Application No. <b>10/551,159</b>	
Applicant(s) <b>Koki TONAKA et al.</b>	Examiner <b>John J. Zimmerman</b>	
Filing Date <b>September 28, 2005</b>	Confirmation No. <b>3164</b>	Art Unit <b>1794</b>

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/J.Z./	JP 2001-200352	07/24/2001	JP			Abstract	
/J.Z./	JP 2001-288550	10/19/2001	JP			Abstract	
	<del>JP 2001-279412</del>	<del>10/10/2001</del>	<del>JP</del>			<del>Abstract</del>	
/J.Z./	JP 2004-204280	07/22/2004	JP			Abstract	

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Japanese Office Action dated March 23, 2009 issued in corresponding Japanese Application No. 2004-027623
	Japanese Office Action dated December 28, 2008 issued in corresponding Japanese Application No. 2004-027623
	Yanagihara et al., "MATERIA JAPAN" The Japan Institute of Metals, Vol. 39, No. 5 (2000), pgs. 450-455

EXAMINER /John Zimmerman/	DATE CONSIDERED 08/12/2009
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /J.Z./